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Attorney's Docket No. 5649-1123IP

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Doh et al.

Confirmation No.: 5066

Serial No.: 10/659,945

Group Art Unit: 2813

Filed: September 10, 2003

Examiner: Laura M. Schillinger

For: *Post Thermal Treatment Methods of Forming High Dielectric Layers Over Interfacial Layers in Integrated Circuit Devices*

Date: July 26, 2005

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT  
FOR KOREAN OFFICE ACTION**

Sir:

Attached is a Supplemental Form PTO-1449 listing documents cited in the Notice to Submit a Response for Korean patent application 10-2003-61702. Each document listed on the attached PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of any listed foreign patent document and/or non-patent literature, including the Office Action, is enclosed. A copy of any listed U.S. patent and/or U.S. patent application publication is not provided herewith in accordance with the amendment by the U.S. Patent and Trademark Office of requirements under 37 C.F.R. § 1.98(a)(2)(ii) effective October 21, 2004.

It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. §1.56 and Section 609 of the MPEP.

No fee is believed due; however, the Commissioner is hereby authorized to charge any deficiency or credit any refund to Deposit Account No. 50-0220.

Respectfully submitted,

  
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**Certificate of Mailing under 37 CFR 1.8**

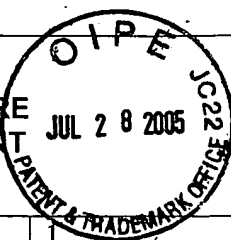
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 26, 2005.

  
Sheena L. Donnelly

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 1 of 1

**Complete if Known**

Application Number	10/659,945
Filing Date	September 10, 2003
First Named Inventor	Seok-Joo Doh
Group Art Unit	2813
Examiner Name	Laura M. Schillinger
Attorney Docket Number	5649-11231P

**U.S. PATENTS AND PATENT PUBLICATIONS**

Examiner Initials*	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code (if known)		
	1.	US-2002/0115252		Haukka et al.	08-22-2002
		US-			
		US-			
		US-			
		US-			
		US-			

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Translation
		Office	Number	Kind Code (if known)			
	2.	KO	10-2003-0027180		Hynix Semiconductor, Inc.	04-07-2003	Abstract

**OTHER NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T
	3.	Notice to Submit a Response for Korean patent application 10-2003-61702 mailed on April 27, 2005	Yes

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.